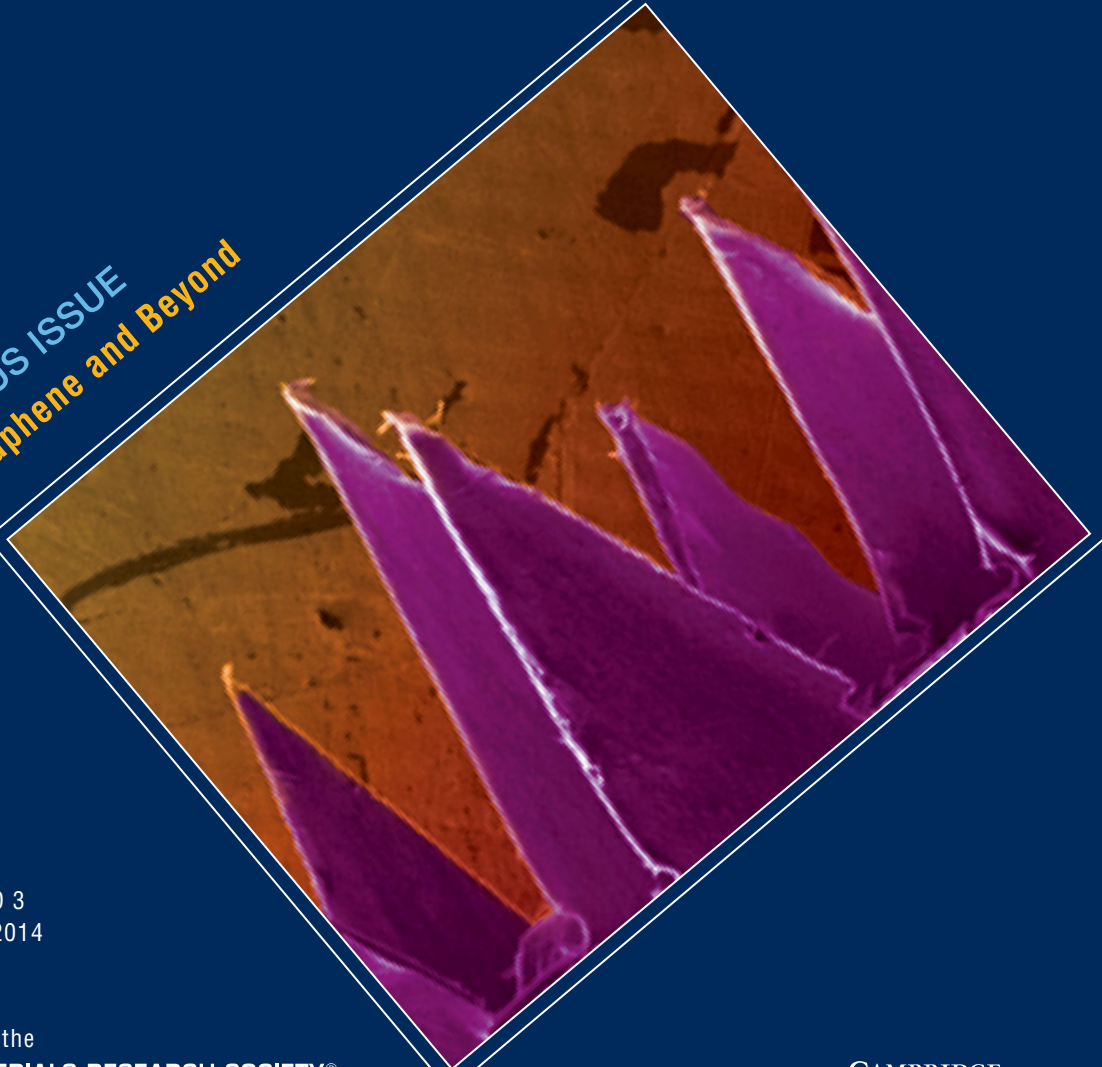




Journal of  
MATERIALS RESEARCH

FOCUS ISSUE  
Graphene and Beyond



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Cover: FIG. 7(a). SEM image of three CNT films stacked together. [S. Fairchild, J. Bulmer, M. Sparkes, J. Boeckl, M. Cahay, T. Back, P.T. Murray, G. Gruen, M. Lange, N.P. Lockwood, F. Orozco, W. O'Neill, C. Paukner, and K.K.K. Koziol: Field emission from laser cut CNT fibers and films. p. 392].

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